



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of: SINGH et al.

Application No.: 10/082,010

Examiner:

Date Filed: February 22, 2002

Group: 2812

RECEIVED

MAR 09 2004

For: SLURRY AND METHOD FOR CHEMICAL MECHANICAL POLISHING
OF METAL STRUCTURES INCLUDING REFRACTORY METAL
BASED BARRIER LAYERS

CERTIFICATE UNDER 37 CFR 1.8(a)

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 1, 2004.

Neil R. Jetter Reg. No. 46,803

PETITION FOR RETROACTIVE EXTENSION OF TIME

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is a Petition for Retroactive Extension of Time pursuant to 37 CFR § 1.136. The Commissioner is hereby authorized to charge the fee in the amount of \$55.00 for a one (1) month extension of time pursuant to 37 CFR § 1.17(a)(1), as well as any underpayment to Deposit Account No. 50-0951. A duplicate copy of this communication is enclosed.

Respectfully submitted,

Date: 3/1/04

Neil R. Jetter, Reg. No. 46,803
AKERMAN SENTERFITT
222 Lakeview Avenue, Suite 400
West Palm Beach, FL 33401
Tel. No. 561-653-5000
Fax No. 561-659-6313

Docket No. 5853-224

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